#### **Initial Information Data Sheet**

#### Inv ntor Information

Inventor One Given Name:

Family Name: Name Suffix:

Postal Address Line One

Postal Address Line Two Postal Address Line Three

City: Country:

Postal or Zip Code: Citizenship Country:

Inventor Two Given Name:

Family Name: Name Suffix:

Postal Address Line One Postal Address Line Two Postal Address Line Three

City: Country:

Postal or Zip Code: Citizenship Country:

Inventor Three Given Name:

Family Name: Name Suffix:

Postal Address Line One Postal Address Line Two Postal Address Line Three

City: Country:

Postal or Zip Code: Citizenship Country: Takayuki TOSHIMA

c/o Tokyo Electron Kyushu Limited,

Process Development Center 650, Mitsuzawa, Hosaka-cho Nirasaki-shi, Yamanashi-ken

**JAPAN** 

Japan

Naoki SHINDO

c/o Tokyo Electron Kyushu Limited,
Process Development Center
650, Mitsuzawa, Hosaka ebo

650, Mitsuzawa, Hosaka-cho Nirasaki-shi, Yamanashi-ken

**JAPAN** 

Japan

Tadashi IINO

c/o Tokyo Electron Kyushu Limited,

Process Development Center 650, Mitsuzawa, Hosaka-cho Nirasaki-shi, Yamanashi-ken

JAPAN

Japan

#### **Correspondenc Information**

Name Line One: David L. Fehrman

Name Line Two: Morrison & Foerster LLP

Address Line One: 555 W. 5th Street

Address Line Two: 35th Floor City: Los Angeles

State or Province: CA

Postal or Zip Code: 90013-1024
Telephone: 213-892-5601
Fax: 213-892-5454

Electronic Mail: dfehrman@mofo.com

### **Application Information**

Title Line One: SUBSTRATE PROCESSING METHOD

Title Line Two:

AND SUBSTRATE PROCESSING APPARATUS

Total Drawing Sheets: 10 Formal Drawings?: Yes

Application Type: non-provisional Docket Number: 199372003500

#### **Representative Information**

Representative Customer Number:

25224

PATENT TRADEMARK OFFICE

## **Continuity Information**

This application is a: > Application One: Filing Date:

which is a:

>>Application Two:

Filing Date:

which is a:

>>>Application Three:

Filing Date:

# **Prior Foreign Applications**

Foreign Application One:

Filing Date: Country:

Priority Claimed:

Foreign Application Two:

Filing Date: Country:

**Priority Claimed:** 

2000-304375 October 4, 2000

Japan

Yes

2001-41482

February 19, 2001

Japan Yes

### **Assignee Information**

Assignee:

**TOKYO ELECTRON LIMITED**